

**PATENT APPLICATION**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Masaki KATO et al.

Application No.: 09/828,914

Docket No.: 109187

Filed: April 10, 2001

For: EXPOSURE APPARATUS, METHOD FOR MANUFACTURING THEREOF AND  
METHOD FOR MANUFACTURING MICRODEVICE

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**REQUEST FOR CORRECTION OF PALM RECORDS**

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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. Also attached is a corrected application data sheet. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff  
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JAO:TJP/mlb

Date: January 22, 2002

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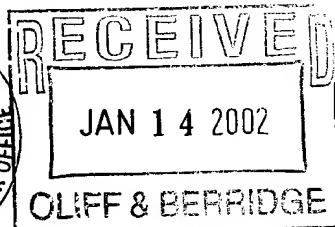
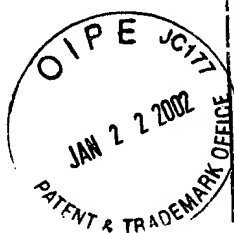
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/828,914	04/10/2001	2851	2358	109187	16	66	10

25944  
OLIFF & BERRIDGE, PLC  
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CONFIRMATION NO. 7191  
CORRECTED FILING RECEIPT



Date Mailed: 01/08/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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## Assignment For Published Patent Application

NIKON CORPORATION; *Tokyo, Japan*

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2000-110529 04/12/2000  
JAPAN 2000-125126 04/26/2000

If Required, Foreign Filing License Granted 06/07/2001

Projected Publication Date: 03/14/2002

Non-Publication Request: No

Early Publication Request: No

## Title

Exposure apparatus, method for manufacturing thereof and method for manufacturing microdevice

RECEIVED  
JAN 29 2002  
TO 2000 MAIL ROOM

Preliminary Class

355

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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**Correspondence Information**

Correspondence Customer Number:: 25944

**Application Information**

Title Line One:: EXPOSURE APPARATUS, METHOD FOR  
Title Line Two:: MANUFACTURING THEREOF AND METHOD  
Title Line Three:: FOR MANUFACTURING MICRODEVICE  
Total Drawing Sheets:: 16  
Docket Number:: 109187

**Prior Foreign Applications**

Foreign Application One:: 2000-110529  
Filing Date:: April 12, 2000  
Country:: JAPAN  
Priority Claimed:: YES  
Foreign Application Two:: 2000-125126  
Filing Date:: April 26, 2000  
Country:: JAPAN  
Priority Claimed:: YES

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